

Title (en)  
SENSOR AND METHOD FOR THE PRODUCTION THEREOF

Title (de)  
SENSOR UND VERFAHREN ZU DESSEN HERSTELLUNG

Title (fr)  
DETECTEUR ET PROCEDE DE PRODUCTION CORRESPONDANT

Publication  
**EP 1711803 A1 20061018 (DE)**

Application  
**EP 05707905 A 20050201**

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Abstract (en)  
[origin: WO2005075969A1] The invention concerns a sensor with silicon-containing components from whose sensitive detection element electrical signals relevant to a present analyte can be read out by means of a silicon semiconductor system. The invention is characterized in that the silicon-containing components are covered with a layer made of hydrophobic material in order to prevent unwanted signals caused by moisture.

IPC 8 full level  
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